

Tencor P2



Facts

The Tencor profilometer is a long scan profilometer that is capable of measuring step heights, stress, surface roughness by moving a stylus over a defined step in the film to be measured.

- Model P2
- Pieces to 8 inch wafers.
- Total step height 100 Å to 300µm with various resolutions (1Å at 10µm scale)
- Scan length up to 200 mm.
- Stylus radius is 12 microns

Personnel

- Tool Engineer - [John Nash](#)
- Process Engineer - [Sean O'Brien](#)
- Process Engineer - [Patricia Meller](#)

Manuals & Users

- [Tencor P2 Profilometer Manual](#)
- [Tencor P2 Profilometer Certification Checklist](#)